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1751
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Uchiyama et al.

Application No.: 10/007,119

Group No.: 1751

Filed: October 26, 2001

Examiner: Unknown

For: CHEMICAL VAPOR DEPOSITION METHOD OF MAKING LAYERED SUPERLATTICE MATERIALS USING TRIMETHYLBISMUTH

Box Non-Fee Amendment

Assistant Commissioner for Patents

Washington, DC 20231

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